


AMENDMENT TRANSMITTAL LETTER (Large Entity)				Docket No. FIS920000372US1	
Applicant(s): S. SUNDAR KUMAR IYER ET AL.					
Serial No. 09/878,556	Filing Date 09/11/2001	Examiner J. CHEN	Group Art Unit 2813		
Invention: METHOD OF FORMING VARIABLE OXIDE THICKNESS ACROSS SEMICONDUCTOR CHIPS					
<u>TO THE COMMISSIONER FOR PATENTS:</u>					
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	22 -	22 =	0 x	\$18.00	\$0.00
INDEP. CLAIMS	6 -	6 =	0 x	\$84.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00
<input checked="" type="checkbox"/> No additional fee is required for amendment. <input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of _____ <input type="checkbox"/> A check in the amount of _____ to cover the filing fee is enclosed. <input checked="" type="checkbox"/> The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 09-0458 <input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16. <input type="checkbox"/> Any patent application processing fees under 37 CFR 1.17.					
 _____ Signature			Dated: July 1, 2003		
Sean F. Sullivan Reg. No. 38,328 Cantor Colburn LLP 55 Griffin Road South Bloomfield, CT 06002 860-286-2939 Customer Service No. 29371 Confirmation No. 3210			FAX RECEIVED JUL 01 2003 TECHNOLOGY CENTER 2800		
CC:			I certify that this document and fee is being deposited on _____ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. _____ Signature of Person Mailing Correspondence _____ Typed or Printed Name of Person Mailing Correspondence		

CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)Applicant(s): **S. SUNDAR KUMAR IYER ET AL.**

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06/11/2001

Examiner

J. CHEN

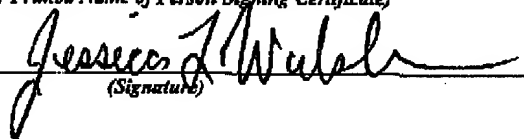
Group Art Unit

2813Invention: **METHOD FOR FORMING VARIABLE OXIDE THICKNESS ACROSS SEMICONDUCTOR CHIPS**

I hereby certify that this

Transmittal and Amendment*(Identify type of correspondence)*is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. 703-872-9318)

on

July 1, 2003*(Date)*Jessica L. Walsh*(Typed or Printed Name of Person Signing Certificate)*
(Signature)

Note: Each paper must have its own certificate of mailing.

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: S. SUNDAR KUMAR IYER, ET AL.)
Serial No.: 09/878,556) Group Art Unit: 2813
Filed: June 11, 2001) Examiner: Chen, J.
For: METHOD OF FORMING VARIABLE)
OXIDE THICKNESS ACROSS) Confirmation No.: 3210
SEMICONDUCTOR CHIPS)

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Office Action mailed April 7, 2003, please amend the
Application as follows:

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